JACOBSON HOLMAN, PLLC 400 SEVENTH STREET, N.W. WASHINGTON, D.C. 20004-2201

LIST OF PATENTS AND PUBLICATIONS FOR APPLICANT'S INFORMATION DISCLOSURE STATEMENT

ATTY. DOCKET NO.: P69147US0 SERIAL NO.: New Application					GROUP ART UNIT: Not Yet Assigned						
SERIAL NO.: New Application APPLICANT(S): Kwang Hyo CHUNG, et					- Filling DATE: September 29, 2003						
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a	AA	6,271,040	08/07/01	Buech	ler	G01N	21/85	07/30/97			
	AB	6,296,020	10/02/01	_McNeely	et al.	F15B	21/00	10/13/99			
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		Phillip G. Wapner, et al.; "Utilization of surface tension an wettability in the design and operation of microsensors"; Sensors and Actuators B 71 (2000); pp. 60-67.									
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[•] EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant(s).

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